

Notice of References Cited	Application/Control No. 10/569,827		Applicant(s)/Patent Under Reexamination GIN ET AL.	
	Examiner CHIA-WEI A. CHEN		Art Unit 2622	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0051578	05-2002	Imagawa et al.	382/224
*	B	US-6,377,191	04-2002	Takubo, Masayuki	340/937
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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